

[10191/3980]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER
Serial No. : 10/519,724
Filed : December 28, 2004
For : DEVICE AND METHOD FOR THE PRODUCTION OF
CHLORINE TRIFLUORIDE AND SYSTEM FOR
ETCHING SEMICONDUCTOR SUBSTRATES USING
THIS DEVICE
Examiner : Rakesh Dhingra
Art Unit : 1763
Confirmation No. : 5180

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on:

Date: February 5, 2008

Signature: /Clifford A. Ulrich/ (Reg. No. 42,194)
Clifford A. Ulrich

RESPONSE

S I R:

In response to the Office Action of October 1, 2007, kindly amend the above-captioned application without prejudice as follows:

Remarks begin on page 2 of this paper.